

**Notice of References Cited**

Application/Control No.

10/571,288

Applicant(s)/Patent Under  
Reexamination  
HEEB ET AL.

Examiner

Nicholas P. D'Aniello

Art Unit

1793

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,300,209	04-1994	Mori, Hisatoshi	205/325
*	B	US-3,986,897	10-1976	McMillan et al.	438/510
	C	US-			
	D	US-			
	E	US-			
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	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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